

LASER-INDUCED DAMAGE THRESHOLD (LIDT) MEASUREMENT REPORT

S-ON-1 (ISO 21254-2) TEST PROCEDURE

SAMPLE: M0050867 LOT0045568 ID 63517

Request from

| | |
|----------------|--|
| Address | Altechna Mokslininku st. 6A 08412 Vilnius Lithuania |
| Contact person | Aurelija Vasiljeva |
| Purchase order | PU0019033 |

Testing institute

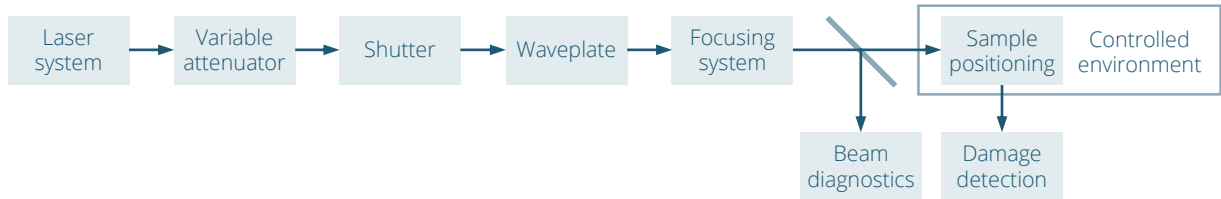
| | |
|------------|--|
| Address | UAB Lidaris Saulėtekio al. 10 10223 Vilnius Lithuania |
| Tester | Lina Vigricaite |
| Test date | 30/09/2020 |
| Sale order | SO2030 |
| Test ID | YXX49Y |

Specimen

| | |
|-----------|--|
| Name | M0050867 LOT0045568 ID 63517 |
| Type | HR Dielectric Coating (HR(Rs>99,8% Rp>99,3%))@ 527-532) |
| Packaging | Plastic box |

TEST EQUIPMENT

Test setup



Laser and its parameters

| | |
|---|---------------------------|
| Type | Q-switched, seeded Nd:YAG |
| Manufacturer | InnoLas Laser |
| Model | SpitLight Hybrid |
| Central wavelength | 532.0 nm |
| Angle of incidence | 45.0 deg |
| Polarization state | Linear P |
| Pulse repetition frequency | 100 Hz |
| Spatial beam profile in target plane | TEM00 |
| Beam diameter in target plane (1/e ²) | (226.6 ± 2.8) μm |
| Longitudinal pulse profile | Single longitudinal mode |
| Pulse duration (FWHM) | (5.7 ± 0.3) ns |
| Pulse to pulse energy stability (SD) | 1.8 % |

Energy/power meter

| | |
|----------------------|------------|
| Manufacturer | Ophir |
| Model | PE50-DIF-C |
| Calibration due date | 2021-06-01 |

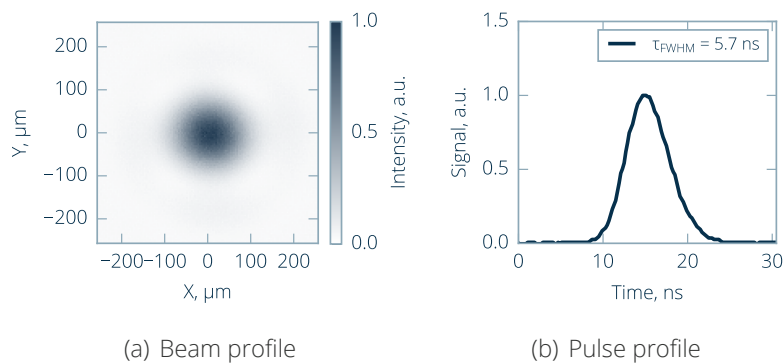


Figure 1. Laser parameters used for measurements.

TEST SPECIFICATION

Definitions and test description

Laser-induced damage (LID) is defined as any permanent laser radiation induced change in the characteristics of the surface/bulk of the specimen which can be observed by an inspection technique and at a sensitivity related to the intended operation of the product concerned. Laser-induced damage threshold (LIDT) is defined as the highest quantity of laser radiation incident upon the optical component for which the extrapolated probability of damage is zero. ¹

LID of the sample is investigated by performing a standardized S-on-1 test procedure.² LIDT value is determined by fitting experimental damage probability data with a model derived for a Poisson damage process assuming degenerate defect ensemble. ³

Test sites

| | |
|--------------------------------|-----------|
| Number of sites | 209 |
| Arrangement of sites | Hexagonal |
| Minimum distance between sites | 750 µm |
| Maximum pulses per site | 1000 |

Analysis information

| | |
|-------------------|-----------------------|
| Online detection | Scattered light diode |
| Offline detection | Nomarski microscope |
| Software version | e254241 - 41bd8ff |

Test environment

| | |
|-------------------------------|-------|
| Environment | Air |
| Cleanroom class (ISO 14644-1) | ISO7 |
| Pressure | 1 bar |
| Temperature | 21 C |
| Humidity | 50 % |

Sample preparation

| | |
|---------------------|------------------------------|
| Storage before test | Normal laboratory conditions |
| Dust blow-off | None |
| Cleaning | None |

¹ISO 21254-1:2011: Lasers and laser-related equipment - Test methods for laser-induced damage threshold - Part 1: Definitions and general principles, International Organization for Standardization, Geneva, Switzerland (2011)

²ISO 21254-2:2011: Lasers and laser-related equipment - Test methods for laser-induced damage threshold - Part 2: Threshold determination, International Organization for Standardization, Geneva, Switzerland (2011)

³J. Porteus and S. Seitel, Absolute onset of optical surface damage using distributed defect ensembles, Applied Optics, 23(21), 3796-3805 (1984)

LIDT TEST RESULTS

LIDT VALUE

| | | |
|-----------------------|--|--|
| 10 ³ -on-1 | 15.2 ^{+1.6} / _{-3.1} J/cm ² | 20.1 ^{+2.2} / _{-4.2} J/cm ² (scaled to 10.0 ns) |
|-----------------------|--|--|

CHARACTERISTIC DAMAGE CURVE

Table 1: Estimated LIDTs from fitting model for sample M0050867 LOT0045568 ID 63517.

| Test mode | Threshold (Online detection - scattering) | Threshold (Online detection - scattering) scaled to 10.0 ns | Threshold (Offline detection - microscopy) | Threshold (Offline detection - microscopy) scaled to 10.0 ns |
|-----------------------|--|---|--|--|
| 10-on-1 | 15.2 ^{+1.6} / _{-3.1} J/cm ² | 20.1 ^{+2.2} / _{-4.2} J/cm ² | - | - |
| 10 ² -on-1 | 15.2 ^{+1.6} / _{-3.1} J/cm ² | 20.1 ^{+2.2} / _{-4.2} J/cm ² | - | - |
| 10 ³ -on-1 | 15.2 ^{+1.6} / _{-3.1} J/cm ² | 20.1 ^{+2.2} / _{-4.2} J/cm ² | 15.2 ^{+1.6} / _{-3.1} J/cm ² | 20.1 ^{+2.2} / _{-4.2} J/cm ² |

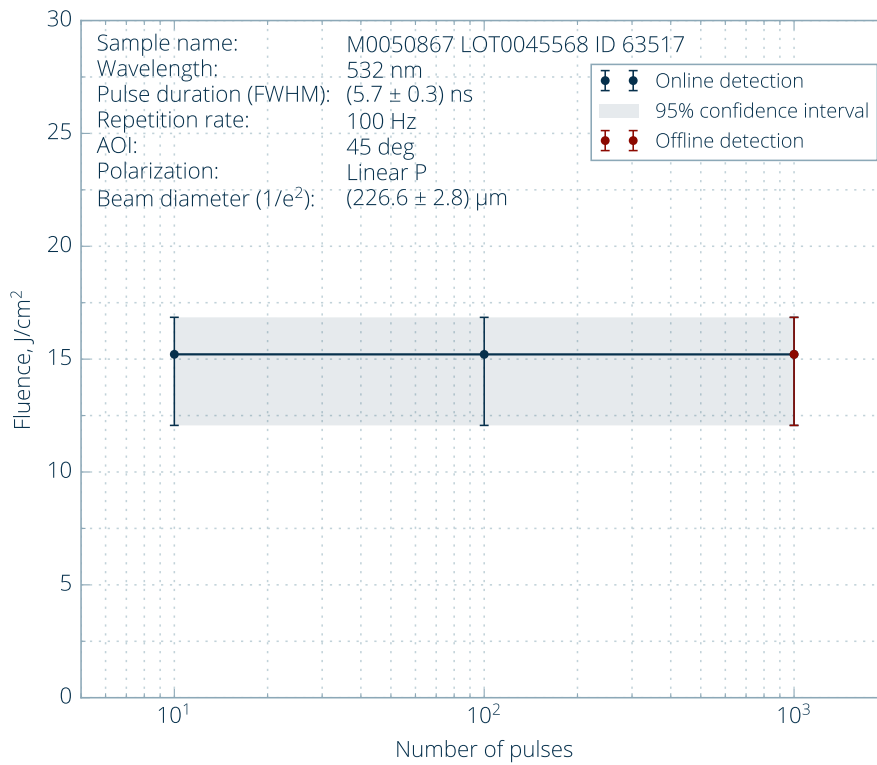
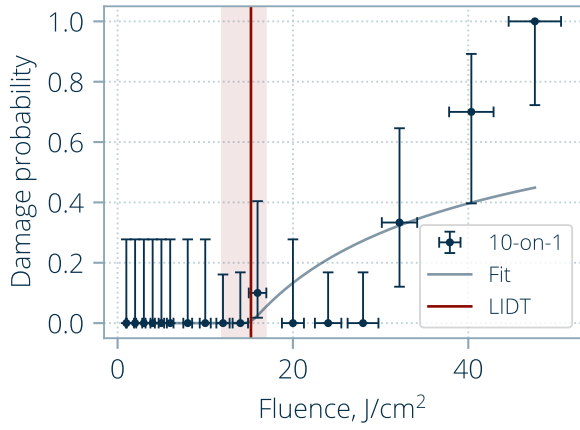
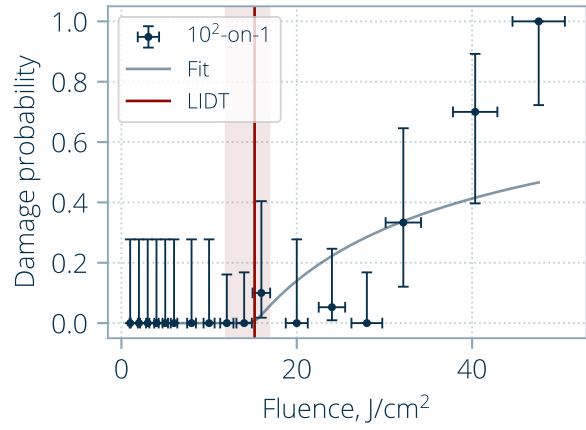


Figure 2. Characteristic damage curve.

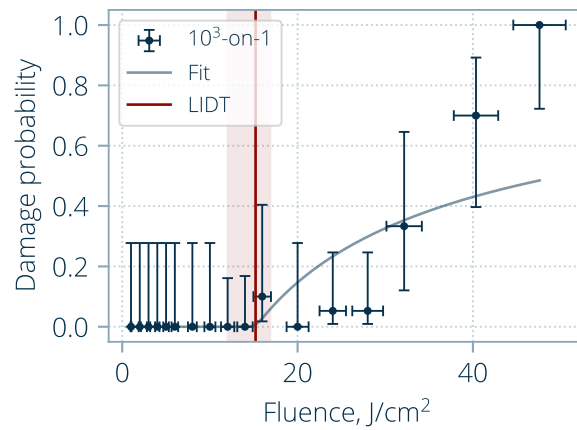
DAMAGE PROBABILITY (ONLINE DETECTION)



(a) 10-on-1



(b) 10²-on-1



(c) 10³-on-1

Figure 3. Damage probability plots.

DAMAGE PROBABILITY (OFFLINE DETECTION)

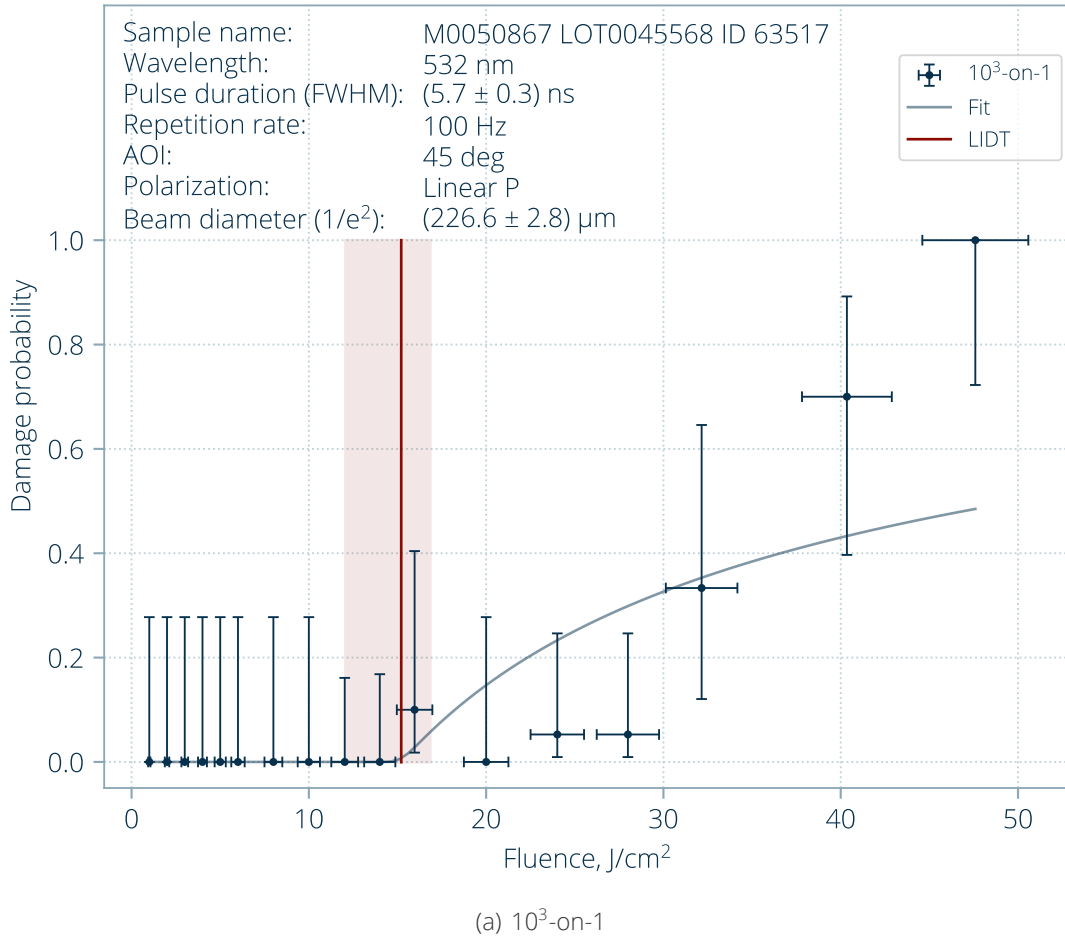


Figure 4. Damage probability plot.

TYPICAL DAMAGE MORPHOLOGY (OFFLINE DETECTION)

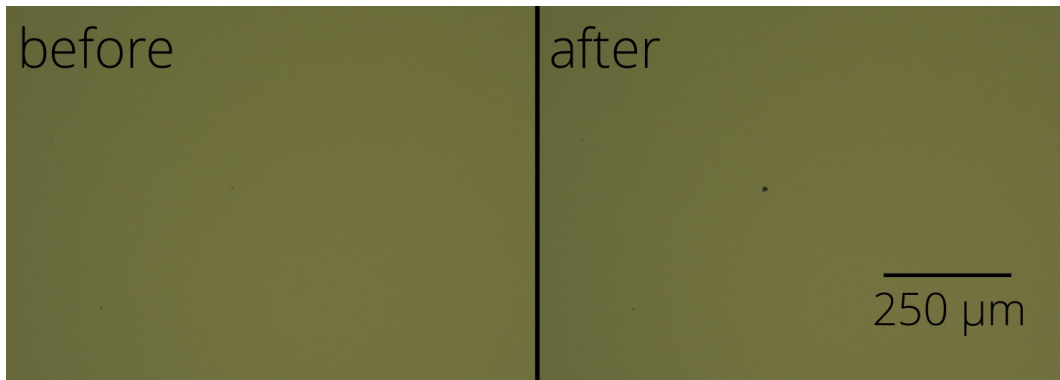


Figure 5. Typical damage morphology: fluence 15.6 J/cm², damage after 4 pulse(s).

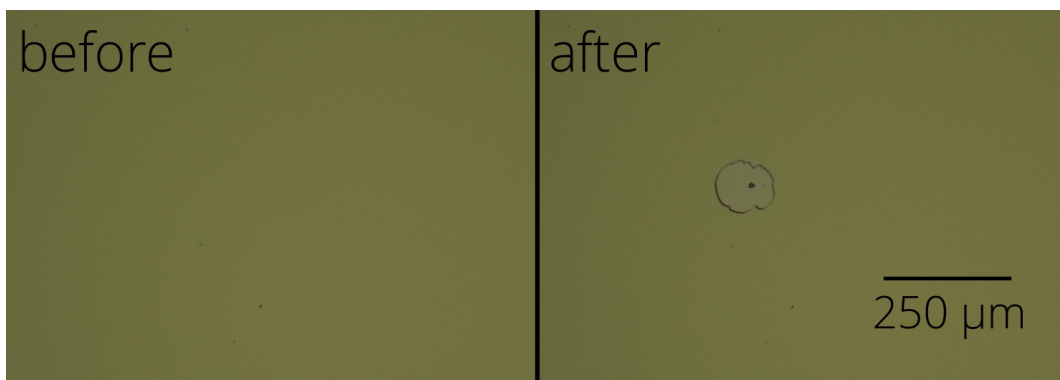


Figure 6. Typical damage morphology: fluence 40.6 J/cm², damage after 2 pulse(s).

TECHNICAL NOTES

TECHNICAL NOTE 1: Oblique incidence

According to the ISO 21254-2:2011 standard, for spatial beam profiling perpendicular to the direction of beam propagation and angles of incidence differing from 0 degrees, the cosine of the angle of incidence is included in the calculation of the effective area, which leads to correct evaluation of laser fluence at different angles of incidence (Figure 7).

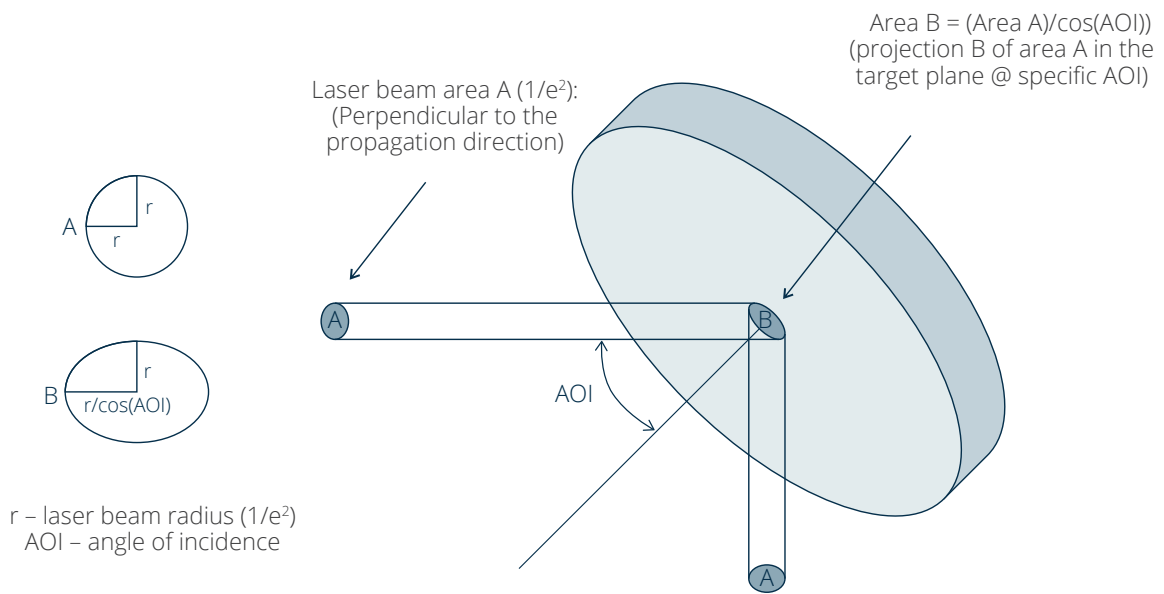


Figure 7. Oblique incidence.